



JG03 Rec'd PCT/PTO

27 FEB 2002

PCT #4
10/21/2

Attorney Docket No. 5000.113

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Slater
Serial No.: 09/787,189
Filed: March 15, 2001
For: LOW TEMPERATURE FORMATION OF
BACKSIDE OHMIC CONTACTS FOR
VERTICAL DEVICES

February 11, 2002

Assistant Commissioner for Patents
Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT
CITATION UNDER 37 C.F.R. 1.97

Sir:

Attached is a list of fifteen (15) documents on form PTO-1449, some of which are cited in the International Search Report for the corresponding International Application PCT/US99/21475. Copies of the Search Report and these documents are enclosed. It is requested that the Examiner consider these documents and officially make them of record in accordance with the provisions of 37 C.F.R. § 1.97 and MPEP § 609.

Respectfully submitted,

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Complete if Known

Application Number	09/787,189
Filing Date	March 15, 2001
First Named Inventor	Slater
Group Art Unit	
Examiner Name	
Attorney Docket Number	5000.113

Sheet	1	of	2
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[illegible][illegible]Date
Considered

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the

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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 2 of 2

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Application Number	09/787,189
Filing Date	March 15, 2001
First Named Inventor	Slater
Group Art Unit	
Examiner Name	
Attorney Docket Number	5000.113

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	12	SPIEB (aka "Spiess"), Aluminum implantation of p-SiC for ohmic contacts, First European Conference on Silicon Carbide and Related Materials (ECSCRM 96), Oct. 6-9, 1996, pp. 1414-1419, Vol. 6, no. 10, Elsevier, Switzerland	
	13	DEV ALOK ET AL, Low Contact Resistivity Ohmic Contacts to 6H-Silicon Carbide, Proceedings of the International Electron Devices Meeting, 1993, pp. 691-694, IEEE, New York	
	14	CHEN ET AL., Contact Resistivity of Re, Pt and Ta Films on n-Type Beta-SiC: Preliminary Results, Materials Science and Engineering, 01/01/1995, pp. 185-189, Vol. B29, no. 1/03, Elsevier Sequoia, Lausanne	
	15	PORTER ET AL, A critical review of ohmic and rectifying contacts for silicon carbide, Materials Science and Engineering, 11-01-1995, pp. 83-105, Vol. B34, no. 2/03, Elsevier Sequoia, Lausanne	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.

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